

<b>Form 1449 (Modified)</b>  <b>Information Disclosure</b> <b>Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Attorney Docket No.</b>	APL1P211/P2656
	<b>Application No.:</b>	09/816,290
	<b>Applicant</b>	Michael F. Culbert
	<b>Filing Date</b>	March 21, 2001
	<b>Group</b>	2621
		Page 1 of 1

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A.						
	B.						
	C.						
	D.						

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
/DC/	E.	2000-102007	4/7/00	Japan			X	
/DC/	F.	2001-25024	1/26/01	Japan			X	
/DC/	G.	2000-152243	5/30/00	Japan			X	
/DC/	H.	9-69949	3/11/97	Japan			X	
/DC/	I.	8-265685	10/11/96	Japan			X	
/DC/	J.	8-191450	7/23/96	Japan			X	

#### Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
/DC/	K.	Japanese Office Action dated February 6, 2007, from corresponding Japanese Application No. 2002-576447 (English Translation Enclosed).
	L.	
	M.	
	N.	
	O.	
	P.	
	Q.	
	R.	
	S.	
	T.	
	U.	

<b>Examiner</b>	/David Czekaj/	<b>Date Considered</b>	07/30/2007
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.